IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Makoto Yoshino, et al.

Art Unit (parent case):

2829

Serial No.:

TBD

Examiner (parent case): Geyer, Scott B.

Filed:

Herewith

Docket:

T1-29448.1

For:

Semiconductor Package Insulation

Conf. No.:

TBD

I hereby certify that on or before this date the above correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450.

Film And Manufacturing Method

Thereof

PRELIMINARY AMENDMENT

Commissioner for Patents

Alexandria, VA 22313-1450

Sir:

Please enter the following amendment prior to examination of the instant application.

In the Specification:

Please amend the specification by inserting before the first line the sentence:

-- This is a divisional application of Serial No. 09/909,013, filed 07/19/2001. --